

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L4	14273	(laser same (ablat\$3 or cutt\$3 or groov\$3)) same (sapphire or semiconductor or wafer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/10 16:32
L5	546	L4 same cleav\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/10 16:33
L6	40	L5 same (galanium near nitride or "GaN")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/10 16:32
L7	0	6 and ((surface near rough\$3) near "nm")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/10 16:33
L8	0	5 and ((surface near rough\$3) near "nm")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/10 16:33
L9	0	((cleav\$3 same facet) and laser and ( surface near rough\$3) and (nanometer or "nm")).clm.	US-PGPUB; USPAT	OR	OFF	2006/12/10 16:35
L10	0	(cleav\$3 and facet and laser and (surface near rough\$3) and (nanometer or "nm")).clm.	US-PGPUB; USPAT	OR	OFF	2006/12/10 16:35
L11	2	li-zhongli.in.	US-PGPUB; USPAT	OR	OFF	2006/12/10 16:35
L12	40	L5 same (galanium near nitride or "GaN")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/10 16:37
L13	49186	"2" and (surface near rough\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/10 16:37

## EAST Search History

L14	2	12 and (surface near rough\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/12/10 16:37
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